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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**Applicants: *Gabric, et al.*

Docket No.: 2006 VJ 33543 US

Serial No.: 10/586,788

Examiner: TBD

Filed: July 21, 2006

Art Unit: TBD

For: Plasma Excited Chemical Vapor Deposition Method, Silicon/Oxygen/Nitrogen-Containing-Material and Layered Assembly

Mail Stop: Amendment  
Commissioner for Patents  
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Dear Sir:

The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a that may be considered material to the examination of the above-identified application. Copies of the U.S. Patents cited are not being submitted. However, Applicants have included copies of the foreign patents.

No fee is due at this time, as this Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3), before the mailing of a first Office Action on the merits.

Respectfully submitted,

Ira S. Matsil  
Attorney for Applicants  
Reg. No. 35,272

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March 29, 2007

Date

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**Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))**

Date of Deposit: March 29, 2007

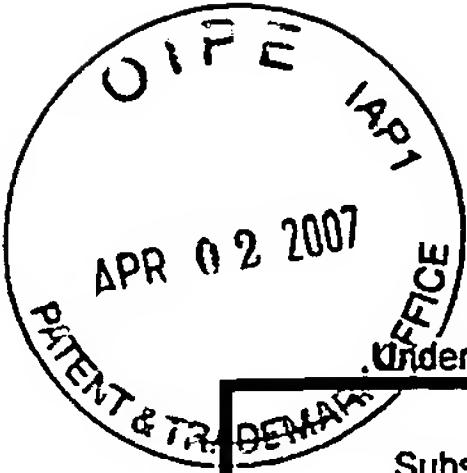
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Form PTO/SB/08a (1 page), citing fourteen (14) references  
Copies of six (6) cited references  
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Respectfully submitted,

  
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Substitute for form 1449A/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	1	Attorney Docket Number	2006 VJ 33543 US
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### U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
	1	US-5,260,600	11-09-1993	Harada	
	2	US-6,211,057 B1	04-03-2001	Lin, et al.	
	3	US-2001/0019903 A1	09-06-2001	Shufflebotham, et al.	
	4	US-6,445,072 B1	09-03-2002	Subramanian, et al.	
	5	US-2003/0176055 A1	09-18-2003	Wu	
	6	US-6,686,643 B2	02-03-2004	Schwarzl, et al.	
	7	US-2004/0084749 A1	05-06-2004	Pamler, et al.	
	8	US-7,033,926 B2	04-25-2006	Schindler, et al.	
	US-				

### FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)				
	9	DE 41 18 165 A1	12-12-1991	Mitsubishi Electric Corp.		
	10	JP 6216122	08-05-1994	Kawasaki Steel Co.		
	11	DE 199 57 302 A1	05-31-2001	Infineon Technologies AG		
	12	DE 101 09 778 A1	09-19-2002	Infineon Technologies AG		
	13	DE 101 25 019 A1	12-05-2002	Infineon Technologies AG		
	14	WO 03 019649 A2	03-06-2003	Infineon Technologies AG		

Examiner Signature	Date Considered
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